

SiPM & MPPC pulse shapes studies

implications to amplification and measurement processes

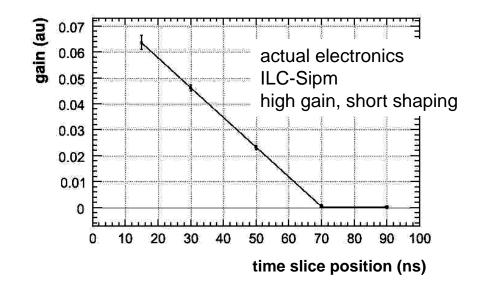


by Benjamin Lutz



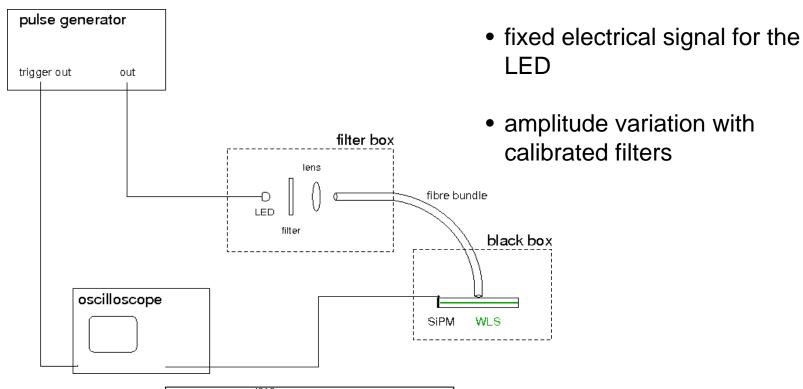
Motivation

- SiPM from different production series show different signal shape
- SiPM coupled via WLS to scintillator change signal shape during saturation
- actual electronics is sensitive to the signal shape in fast shaping mode (but fine for low signals)
- new electronics will use reduced shaping in low gain mode → need input for simulations
- no data for MPPC





Setup



∔150 nF

- high bandwidth connection
- high bandwidth and high resolution oscilloscope (4 GHz 20 Gs)

oscilloscope

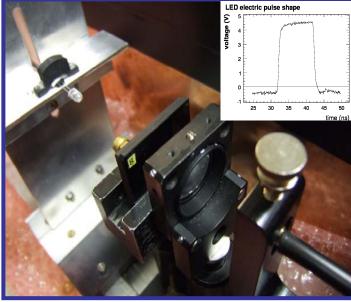
SiPM

50Ω

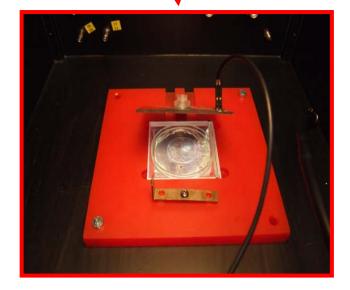


In pictures

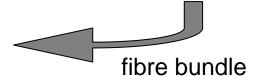




scintillator WLS SiPM

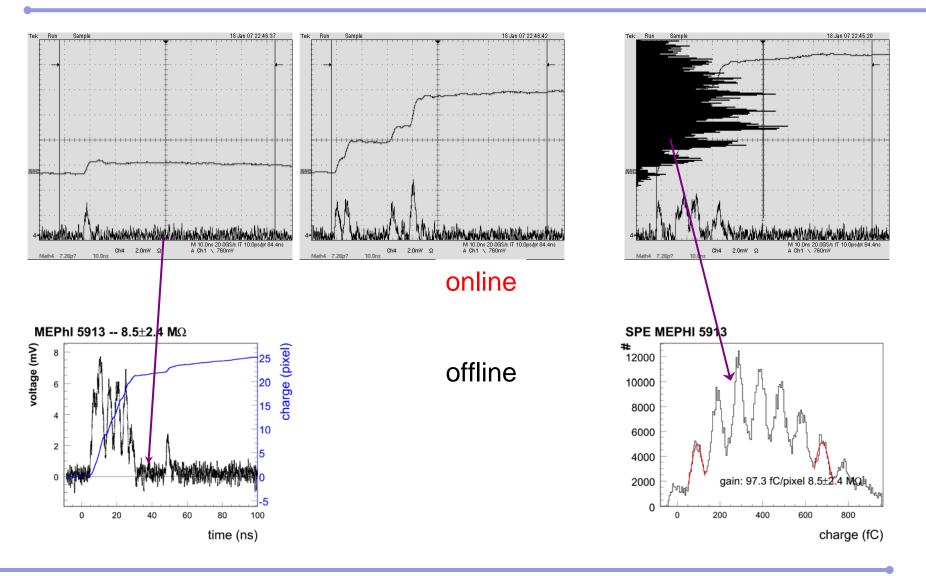


LED & filter





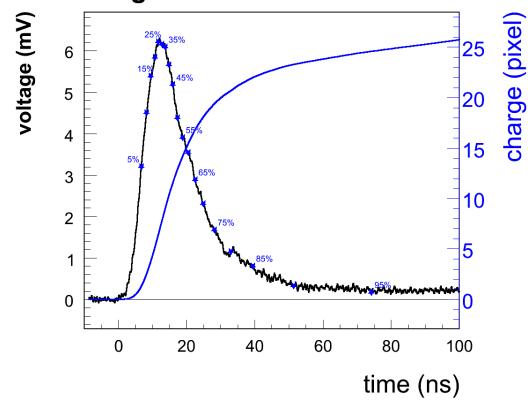
Measurement technique





Single measurement

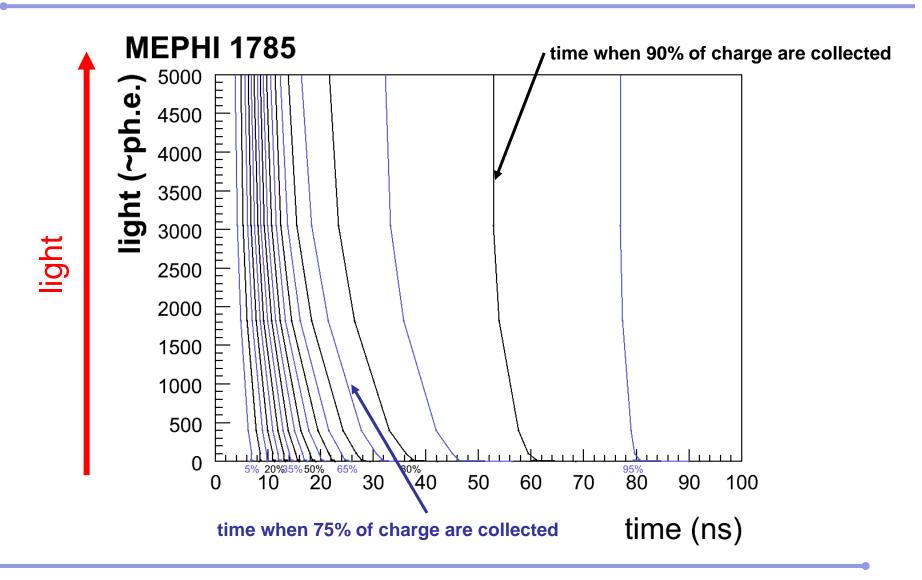
filter 96 avg



- light intensity (by filters)
- total amount of charge
- charge distribution in time

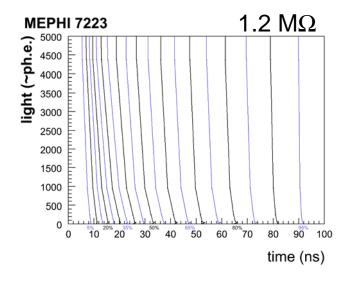


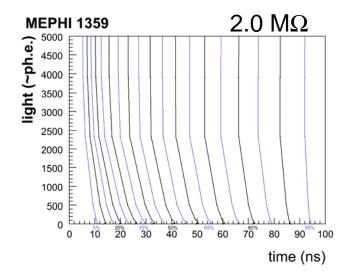
Visualization of result

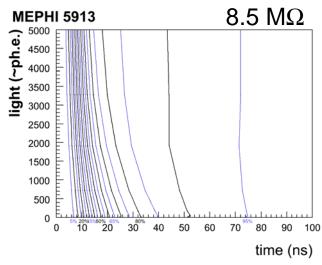


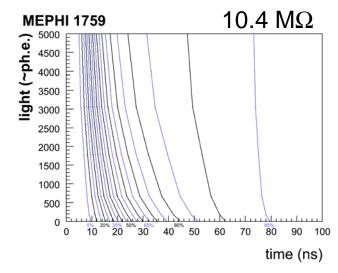


Results for different SiPM series



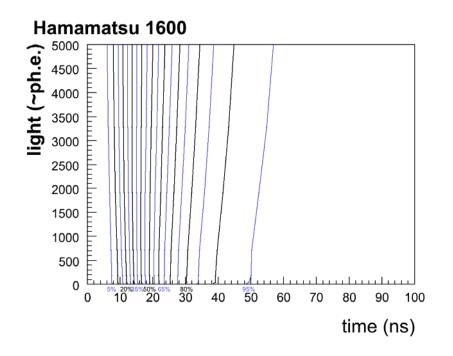


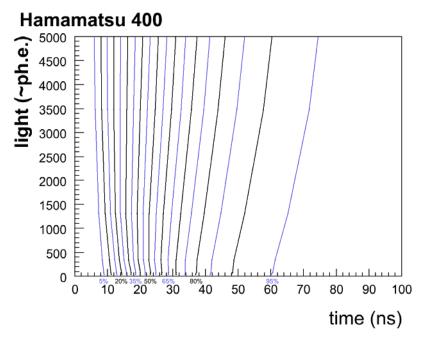






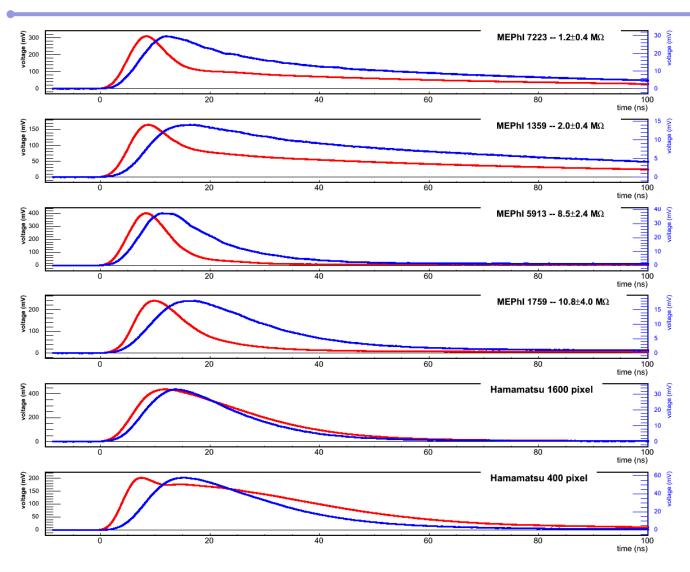
Result for MPPC







Signal shape for different intensities

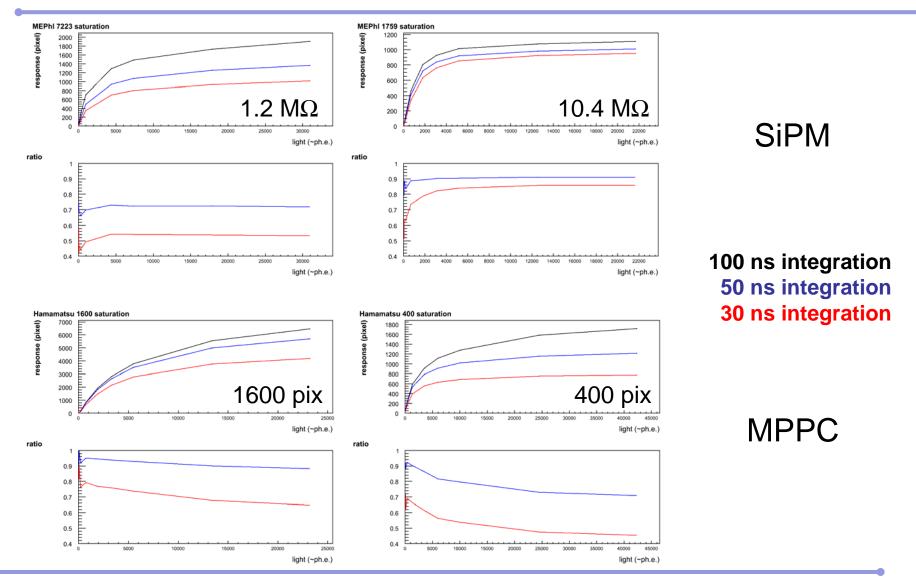


medium light intensity

high light intensity

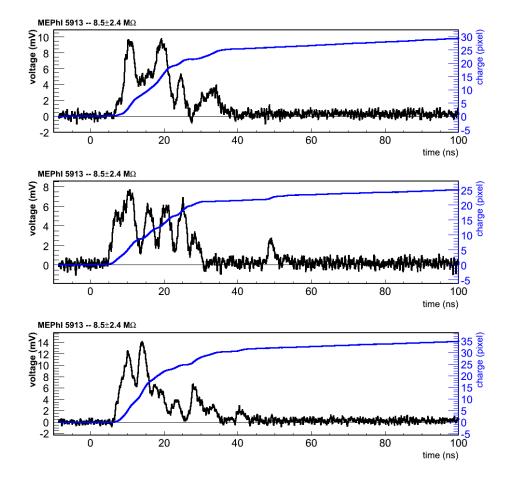


Saturation behavior





The low light intensity limit



three triggers with identical experimental settings

→ signal shape is defined by statistical effects



Summary/Outlook

- Scintillator-WLS-SiPM show various signal shapes depending on
 - quenching resistor (production series)
 - signal amplitude
- shortest shaping of new chip with 50 ns may be "on the edge", but shaping and integrating are not the same
 - → studies necessary
- MPPC saturation is quite different compared to SiPM

future:

- Coupling without WLS
- Simulation studies of new amplifier design with the recorded signals (LAL)



backup

